You must meet the operating limits at all times after you establish them.
(c) If you use an add-on control device other than those listed in Table 1 to this subpart, or wish to monitor an alternative parameter and comply with a different operating limit, you must apply to the Administrator for approval of alternative monitoring under §63.8(f).

## § 63.4893 What work practice standards must I meet?

(a) For any coating operation or group of coating operations for which you use the compliant material option or the emission rate without add-on controls option to demonstrate compliance, you are not required to meet any work practice standards.
(b) For any coating operation or group of coating operations for which you use the emission rate with add-on controls option to demonstrate compliance, you must develop and implement a work practice plan to minimize organic HAP emissions from the storage, mixing, and conveying of coatings, thinners, and cleaning materials used in, and waste materials generated by, the coating operation or group of coating operations for which you use this option; or you must meet an alternative standard as provided in paragraph (c) of this section. The plan must specify practices and procedures to ensure that, at a minimum, the elements specified in paragraphs (b)(1) through (5) of this section are implemented.
(1) All organic-HAP-containing coatings, thinners, cleaning materials, and waste materials must be stored in closed containers. You must ensure that these containers are kept closed at all times except when depositing or removing these materials from the container.
(2) Spills of organic-HAP-containing coatings, thinners, cleaning materials, and waste materials must be minimized.
(3) Organic-HAP-containing coatings, thinners, cleaning materials, and waste materials must be conveyed from one location to another in closed containers or pipes.
(4) Mixing vessels which contain or-ganic-HAP-containing coatings and other materials must be closed except
when adding to, removing, or mixing the contents.
(5) Emissions of organic HAP must be minimized during cleaning of storage, mixing, and conveying equipment.
(c) As provided in $\S 63.6(\mathrm{~g})$, the Administrator may choose to grant you permission to use an alternative to the work practice standards in this section.

## General Compliance Requirements

§ 63.4900 What are my general requirements for complying with this subpart?
(a) The affected source must be in compliance at all times with the emission limitations specified in §63.4890.
(b) You must always operate and maintain your affected source, including all air pollution control and monitoring equipment you use for purposes of complying with this subpart, according to the provisions in $\S 63.6(\mathrm{e})(1)(\mathrm{i})$.
(c) If your affected source uses an emission capture system and add-on control device to comply with the emission limitations in $\S 63.4890$, you must develop a written startup, shutdown, and malfunction plan (SSMP) according to the provisions in §63.6(e)(3). The SSMP must address the startup, shutdown, and corrective actions in the event of a malfunction of the emission capture system or the add-on control device. The SSMP must also address any coating operation equipment that may cause increased emissions or that would affect capture efficiency if the process equipment malfunctions, such as conveyors that move parts among enclosures.
[68 FR 28619, May 23, 2003, as amended at 71 FR 20466, Apr. 20, 2006]

## § 63.4901 What parts of the General Provisions apply to me?

Table 2 to this subpart shows which parts of the General Provisions in §§ 63.1 through 63.15 apply to you.

## Notifications, Reports, and Records

## § 63.4910 What notifications must I submit?

(a) General. You must submit the notifications in $\S \S 63.7$ (b) and (c), 63.8(f)(4), and $63.9(\mathrm{~b})$ through (e), (h), and (j) that

